Rapidly Solidified Crystalline Alloys

Edited by S.K. Das, B.H. Kear and C.M. Adam

(The Metallurgical Society, 1986)

This conference proceedings reports contributions to a May 1985 meeting of the Northeast Regional Section of TMS-AIME and cosponsored by the New Jersey Chapter of TMS and by the Materials Research Society. As the first in what has become a cosponsored series of meetings, its program combined the metals and materials flavors of the sponsors. A great many texts and, in particular, conference proceedings cover rapid solidification. However, because it remains an active field where many unanswered questions remain, this book, itself unremarkable, contains valuable information for practitioners in the field. Overviews on processing methods and on RSP alloy microstructures and properties provide perspectives on a range of ferrous and nonferrous systems.

Of particular value are the two lead-off papers by M. Cohen and M. Flemings and by W. Boettinger and J. Perepezko which review the field as a whole and discuss the extension of fundamental considerations implicit in solidification phenomena to the rapid regime. These two papers will serve as valuable introductory material for novices in the field for years to come. Although this book was published in 1986, the overview format ensures its continued value to the RSP community.

E. N. Kaufmann is an associate division leader for materials research at Lawrence Livermore National Laboratory.

Rapidly Solidified Metals— A Technological Overview

Edited by T.R. Anantharaman and C. Suryanarayana

(Trans Tech Publications, 1987)

In rapid solidification—often abbreviated RSP for Rapid Solidification Processing—the molten alloy is broken up into small droplets, a thin ribbon or other geometries so that heat can be quickly extracted into

the surrounding gas or into a solid heat sink; consequently cooling rates exceeding 106 K/s are routinely achieved. Alloys thus solidified have metastably extended solubility ranges for many solutes and ultrafine dispersions of second phases; some alloys solidify as metallic glasses. These characteristics have permitted the creation of a great variety of alloys with unusually favorable mechanical or magnetic properties, and within a few years the technique has become commonplace in advanced metallurgy, especially of steels and light alloys.

In the last few years there have been many books (mostly multi-author volumes) devoted to RSP, especially glass formation, including a sourcebook published by ASM and a specially useful survey of RSP crystalline alloys published by TMS-AIME in 1986. The new book under review is an excellent 260-page outline of the whole field. Its principal distinction is a magnificent survey of the varied production techniques, the most comprehensive and up-to-date treatment known to the reviewer. The authors, Indian academic metallurgists, who are experienced both working in the field and writing surveys and bibliographies, have produced not only a fine description of techniques but also a relevant list of references up to 1986. Likewise there is a concise overview of RSP alloys applications, especially up to date on magnetic uses. The bibliographies of all the chapters (except that on the science of metallic glasses) are thorough, and a comprehensive list of secondary sources is included.

The treatment of microcrystalline particular alloy families (steels, aluminum, titanium and other alloys, and glasses) is also sound, though in parts, especially the aluminum alloys, more compressed than one might have wished. A short chapter on quasicrystals seems out of tune with all the rest, being pure science and no technology (quasicrystals have no technology!). However, the inclusion of this chapter can be justified in terms of the disproportionate contribution made by Indian metallurgists to the study of these curious entities.

The book is printed from good cameraready copy and, for once, the potentiality for rapid publication of this technique has been realized. The style is clear, though there is an occasional tendency to geewhizzery, due no doubt to the authors' enthusiasm for their subject.

A good value for the money, this book is recommended as a fine source book.

Robert W. Cahn is a senior associate, Department of Materials Science and Metallurgy, University of Cambridge, U.K. He worked for many years in rapid solidification processing of alloys.

Semiconductor Materials and Process Technology Handbook

Edited by Gary E. McGuire, Noyes Publications, 1988

With the rapid evolution in silicon process technology, maintaining awareness in all aspects of device processing is difficult. At first glance, this handbook appears to solve this problem. Ten chapters cover the critical process areas in Very Large Scale Integration (VLSI) and Ultra Large Scale Integration (ULSI) technology, and each chapter was written by a recognized authority.

The book is organized logically, going from the silicon materials through the process steps required to realize an integrated circuit, with the final chapter discussing the techniques used for materials characterization. Each chapter provides basic background information. In particular, Chapter 7 gives an excellent review of impurity diffusion in silicon while chapter 4 provides a useful summary of orientation dependent etching. Overall, the information provided was too general to be useful and not current with the state of the art.

Few references are noted after 1985 and several important process developments are excluded. Among these are rapid thermal processing for impurity activation and silicon oxidation/nitridization; chemical vapor deposition of refractory materials, particularly selective tungsten process; and low pressure silicon epitaxial growth.

This volume is of limited value to workers in the field as a technical source, falling short of the expectations raised by the title. By attempting to meet the needs of both the experienced engineer and the newcomer to silicon process technology, it achieves neither very well.

Reviewer: Victor A. Wells is senior staff consultant and manager, advanced packaging technology, Unisys Corporation. His recent interests include submicron CMOS technology development and high performance packaging technology.

MRS Publications Catalog Supplement

New Titles



Videotapes



Microforms

Order a copy for yourself and one for a colleague from: MRS Publications Department, 9800 McKnight Road, Suite 327, Pittsburgh, PA 15237; telephone (412) 367-3012; fax (412) 367-4373

70 MRS BULLETIN/APRIL 1989

Visit Booth #506 in San Diego

Leading Books for Researchers

LASER MICROFABRICATION Thin Film Processes and Lithography

edited by

Daniel J. Ehrlich and

Jeffrey Y. Tsao

This book reviews the solid core of fundamental scientific knowledge on laser-stimulated surface chemistry that has accumulated over the past few years. It provides a useful overview for the student and interested non-expert as well as essential reference data (photodissociation cross sections, thermochemical constants, etc.) for the active researcher.

April 1989, c. 602 pages \$89.50 (tentative) ISBN: 0-12-233430-2

SUPERALLOYS, SUPERCOMPOSITES AND SUPERCERAMICS

edited by

John K. Tien and

Thomas Caulfield

A Volume in the MATERIALS SCI-ENCE AND TECHNOLOGY Series

Progress in such strategic applications as jet engines, turbine power generators, rockets and missiles is rate controlled by the development of structural materials with ever higher temperature capabilities and reliability. This book reviews the state of superalloy technology and concurrently covers aspects of alternative high-temperature materials such as superceramics and supercomposites.

May 1989, c. 672 pages \$129.95 (tentative) ISBN: 0-12-690845-1

PHYSICS OF HIGH-T_C SUPERCONDUCTORS

J.C. Phillips

This book provides the reader with a guide to a new subjecthigh-Tc superconductivity based primarily on cuprates. The chemical background and the physical experiments are discussed in the context of prior work on superconductivity in intermetallic compounds so that the reader can easily recognize both the similarities and the differences. Theory is discussed in the context of simple ideas with special emphasis on materials. The theory provides a general framework which embraces both cuprates and intermetallic compounds. Comparisons between the two kinds of materials are frequently used to show the directions of research. This is the first book to provide a unified discussion of all aspects of this subject from a single point of view based on the traditional BCS theory.

January 1989, 408 pages \$49.95/ISBN: 0-12-553990-8

ATOM-PROBE FIELD ION MICROSCOPY AND ITS APPLICATIONS

Toshio Sakurai, A. Sakai, and H.W. Pickering

Here is a comprehensive, up-todate review of the theory, instrumentation, and applications of atom-probe field ion microscopy. This book provides the necessary background information for new entrants to this field, and also covers the details of recent research activities, making it a useful reference for experts. Applications to several topics discussed include: field calibration, field adsorption, surface segregation, semiconductor physics, semiconductor-metal interfaces, and metallurgy. This book contains an extensive bibliography that surveys the research activities in this field.

April 1989, c. 292 pages \$69.50 (tentative) ISBN: 0-12-014582-0

ELECTRONIC MATERIALS Science and Technology

Shyam P. Murarka and Martin C. Peckerar

Written as an intermediate-level text, this book will also be a good reference source for practicing engineers and scientists who are interested in electronic materials and devices. After presenting an introduction to electronic devices, the authors describe the processing of a complementary MOS (CMOS) circuit including fundamental physical and materials concepts. Other areas of electronic material processing covered include crystal growth, oxidation, diffusion, ion implantation, metallization, chemical vapor deposition, lithography concepts and tools, and etching. It also discusses advanced processes and possibilities for the future.

June 1989, c. 470 pages \$49.50 (tentative) ISBN: 0-12-511120-7

SEMICONDUCTOR SILICON CRYSTAL TECHNOLOGY

Fumio Shimura

December 1988, 426 pages \$49.95/ISBN: 0-12-640045-8



ACADEMIC PRESS

Harcourt Brace Jovanovich, Publishers

Book Marketing Department #31049, 1250 Sixth Avenue, San Diego, CA 92101

CALL TOLL FREE 1-800-321-5068

© 1989 by Academic Press, Inc. All Rights Reserved.

Prices subject to change without notice. DK/ES #31049.